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00684.002864 (684.2864)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: H. Nguyen
MITSURO SUGITA, ET AL.)	
	:	Group Art Unit: 2851
Appln. No.: 09/337,040)	
	:	
Filed: June 28, 1999)	
	:	
For: MULTIPLE EXPOSURE METHOD)	June 5, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Introductory Comments

The present Preliminary Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice entitled "Amendments in a Revised Format Now Permitted," a copy of which is attached.

Prior to examination on the merits, please amend the above-identified application as follows:

06/06/2003 SDEH031 00000037 09337040

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